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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/622,871	07/17/2003	Masahiro Murasato	791_203 NP	2911
25191	7590 01/03/2005	EXAMINER		
BURR & BROWN			DOUGHERTY, THOMAS M	
PO BOX 7068 SYRACUSE, NY 13261-7068			ART UNIT	PAPER NUMBER
			2834	
			DATE MAILED: 01/03/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

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		Application No.	Applicant(s)	
		10/622,871	MURASATO ET AL.	
	Office Action Summary	Examiner	Art Unit	_
		Thomas M. Dougherty	2834	
Period for	- The MAILING DATE of this communication ap r Reply	ppears on the cover sheet with the	correspondence address	
THE M - Extens after S - If the p - If NO - Failure Any re	DRTENED STATUTORY PERIOD FOR REP MAILING DATE OF THIS COMMUNICATION sions of time may be available under the provisions of 37 CFR 1 SIX (6) MONTHS from the mailing date of this communication. period for reply specified above is less than thirty (30) days, a re period for reply is specified above, the maximum statutory period to reply within the set or extended period for reply will, by statu- tely received by the Office later than three months after the mailed d patent term adjustment. See 37 CFR 1.704(b).	I. 1.136(a). In no event, however, may a reply be sply within the statutory minimum of thirty (30) d d will apply and will expire SIX (6) MONTHS froute, cause the application to become ABANDON	timely filed ays will be considered timely. on the mailing date of this communication. NED (35 U.S.C. § 133).	
Status				
1)🛛 🗆	Responsive to communication(s) filed on <u>05</u> .	September 2003		
•	•	is action is non-final.		
· -	Since this application is in condition for allow	•	rosecution as to the merits is	
.—	closed in accordance with the practice under	· · · · · · · · · · · · · · · · · · ·		
Dispositio	on of Claims			
•	Claim(s) <u>1</u> is/are pending in the application. Ia) Of the above claim(s) is/are withdra	awn from consideration		
	Claim(s) is/are allowed.			
	Claim(s) <u>1</u> is/are rejected.			
•	Claim(s) is/are objected to.			
	Claim(s) are subject to restriction and/	or election requirement.		
Application	on Papers			
9)∐ Т	The specification is objected to by the Examin	ner.		
10)⊠ T	The drawing(s) filed on <u>703</u> is/are: a) acce	pted or b) objected to by the E	xaminer.	
,	Applicant may not request that any objection to the	e drawing(s) be held in abeyance. S	ee 37 CFR 1.85(a).	
ı	Replacement drawing sheet(s) including the corre	ection is required if the drawing(s) is o	objected to. See 37 CFR 1.121(d).	
11) 🗌 T	The oath or declaration is objected to by the E	Examiner. Note the attached Office	ce Action or form PTO-152.	
Priority u	nder 35 U.S.C. § 119			
a)[∑	Acknowledgment is made of a claim for foreig All b) Some * c) None of: Certified copies of the priority documer Certified copies of the priority documer Copies of the certified copies of the priority documen application from the International Burea	nts have been received. nts have been received in Applica ority documents have been recei	ation No	
* Se	ee the attached detailed Office action for a lis	st of the certified copies not receive	ved.	
Attachment((s)			
	of References Cited (PTO-892)	4) Interview Summa		
3) 🔯 Inform	of Draftsperson's Patent Drawing Review (PTO-948) ation Disclosure Statement(s) (PTO-1449 or PTO/SB/08 No(s)/Mail Date <u>803</u> .	Paper No(s)/Mail 5) Notice of Informal 6) Other:	Date Patent Application (PTO-152)	

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DETAILED ACTION

Claim Rejections - 35 USC § 103The following is a quotation of 35

U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claim 1 is rejected under 35 U.S.C. 103(a) as being unpatentable over Takeuchi et al. (US 6,396,196) in view of Funemi et al. (JP 2000-261283). Takeuchi shows (fig. 3) a piezoelectric/ electrostrictive film type device (1) comprising a piezoelectric/ electrostrictive operation portion (5) in which at least one piezoelectric/electrostrictive layer (5) and at least one pair of electrodes (4, 6) electrically connected to the piezoelectric/ electrostrictive layer (5) are stacked on a substrate (2) formed of a ceramic (see ABSTRACT).

Takeuchi does not note that his device is characterized in that a highly water repellent surface which is modified in such an extent that infiltration of moisture into micro-pores opened in the outer surface of these piezoelectric/ electrostrictive layers or into gaps between the substrate and the piezoelectric/ electrostrictive layer is sufficiently inhibited, is formed on the outer surface of at least the piezoelectric/ electrostrictive layer or the upper electrode.

Funemi et al. show (fig. 1) a piezoelectric/ electrostrictive film type device comprising a piezoelectric/ electrostrictive operation portion (5) in which at least one

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piezoelectric/electrostrictive layer (5) and at least one electrode (3) electrically connected to the piezoelectric/ electrostrictive layer (5); Funemi et al. also show a highly water repellent surface (2) which is modified in such an extent that infiltration of moisture into micro-pores opened in the outer surface of these piezoelectric/ electrostrictive layers (5) or into gaps between the substrate and the piezoelectric/ electrostrictive layer is sufficiently inhibited, is formed on the outer surface of at least the piezoelectric/ electrostrictive layer or the upper electrode (3).

Funemi et al. do not show at least two electrodes, only shown is the excitation electrode. Their piezoelectric/ electrostrictive film type device is not stacked on a substrate (2) formed of a ceramic (see ABSTRACT).

It would have been obvious to one having ordinary skill in the art to employ the highly water repellent surface which is modified in such an extent that infiltration of moisture into micro-pores opened in the outer surface of these piezoelectric/ electrostrictive layers or into gaps between the substrate and the piezoelectric/ electrostrictive layer is sufficiently inhibited, is formed on the outer surface of at least the piezoelectric/ electrostrictive layer or the upper electrode, of Funemi et al., in the device of Takeuchi et al. in order to provide a device superior in resistance to power and weather resistance. Such a design would lengthen the lifetime of the device, thereby reducing replacement costs.

Conclusion

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The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. The remaining prior art cited reads on at least some aspects of the claimed invention.

Direct inquiry to Examiner Dougherty at (571) 272-2022.

December 28, 2004

TOM DOUGHERTY/ PRIMARY EXAMINER